



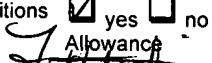
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CONFIRMATION NO. 9828

SERIAL NUMBER 10/500,268	FILING OR 371(c) DATE 06/23/2004 RULE	CLASS 117	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. 92372	
APPLICANTS Masahiko Ando, Kanagawa, JAPAN; Masaru Yuyama, Kanagawa, JAPAN; Shiro Yoshino, Kanagawa, JAPAN;					
** CONTINUING DATA ***** This application is a 371 of PCT/JP02/13477 12/25/2002					
** FOREIGN APPLICATIONS ***** JAPAN 2001-394791 12/26/2001					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged  Examiner's Signature Allowance  Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 20	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 10
ADDRESS Welsh & Katz 120 South Riverside Plaza 22nd Floor Chicago, IL60606-3913					
TITLE Method for vanishing defects in single crystal silicon and single crystal silicon					
FILING FEE RECEIVED 1522	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			